

Notice of References Cited

Application/Control No.

10/080,884

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

DuyVu n Deo

Art Unit

1765

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0117731	08-2002	Kim et al.	257/510
	B	US-6,140,208	10-2000	Agahi et al.	438/437
	C	US-6,037,018	03-2000	Jang et al.	427/579
	D	US-6,180,493	01-2001	Chu, Chih-Hsun	438/437
	E	US-6,251,735	06-2001	Lou, Chine-Gie	438/296
	F	US-6,461,937	10-2002	Kim et al.	438/431
	G	US-6,046,487	04-2000	Benedict et al.	257/510
	H	US-5,190,889	03-1993	Poon et al.	438/437
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.